

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
Michigan, University of	09/16/2008
RECEIVING PARTY DATA	
Name:	National Science Foundation
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PROPERTY NUMBERS Total: 1	
Property Type	Number
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License to the United States Government

Invention Title: Electrical Impedance Tomography of Nanoengineered Thin Films

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Patent or Application Serial No.: 12/209,318

Grant/Contract Numbers: NSF - CMS0528867.

Foreign Applications filed/intended in (countries);


The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government This document is confirmatory of:

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Signed this 16th day of September, 2008.

By: Michael Hallman
(Name of Grantee/Contractor Official)


(Signature)

Title: Patent Administrator

For: University of Michigan
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